

# PROCEEDINGS OF SPIE

## **3D Printed Optics and Additive Photonic Manufacturing II**

**Alois M. Herkommer**  
**Georg von Freymann**  
**Manuel Flury**  
Editors

**6–10 April 2020**  
**Online Only, France**

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Photonics 21 (Germany)  
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Published by  
SPIE

**Volume 11349**

Proceedings of SPIE 0277-786X, V. 11349

SPIE is an international society advancing an interdisciplinary approach to the science and application of light.

3D Printed Optics and Additive Photonic Manufacturing II, edited by Alois M. Herkommer, Georg von Freymann, Manuel Flury, Proc. of SPIE Vol. 11349, 1134901 · © 2020 SPIE · CCC code: 0277-786X/20/\$21 · doi: 10.1117/12.2571662

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Please use the following format to cite material from these proceedings:

Author(s), "Title of Paper," in *3D Printed Optics and Additive Photonic Manufacturing II*, edited by Alois M. Herkommmer, Georg von Freymann, Manuel Flury, Proceedings of SPIE Vol. 11349 (SPIE, Bellingham, WA, 2020) Seven-digit Article CID Number.

ISSN: 0277-786X

ISSN: 1996-756X (electronic)

ISBN: 9781510634701

ISBN: 9781510634718 (electronic)

Published by

**SPIE**

P.O. Box 10, Bellingham, Washington 98227-0010 USA

Telephone +1 360 676 3290 (Pacific Time) · Fax +1 360 647 1445

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